

07/27/01



Docket No.: 57454-178

**UTILITY PATENT APPLICATION
UNDER 37 CFR 1.53(b)**

Box PATENT APPLICATION

Commissioner for Patents

Washington, DC 20231

Sir:

Transmitted herewith for filing is the patent application of:

INVENTOR: Shoichiro NAKAZAWA, Heiji KOBAYASHI

FOR: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Enclosed are:

- ☒ 15 pages of specification, claims, abstract.
- ☒ Declaration and Power of Attorney.
- ☒ Priority Claimed.
- ☒ Certified copy of Japanese Patent Application No. 2001-016522
- ☒ 10 sheets of formal drawing.
- ☒ An assignment of the invention to MITSUBISHI DENKI KABUSHIKI KAISHA,
AND RYODEN SEMICONDUCTOR SYSTEM
ENGINEERING CORPORATION
- ☐ and the assignment recordation fee.
- ☐ An associate power of attorney.
- ☐ A verified statement to establish small entity status under 37 CFR 1.9 and 37 CFR 1.27.
- ☒ Information Disclosure Statement, Form PTO-1449 and reference.
- ☒ Return Receipt Postcard
- ☐

The filing fee has been calculated as shown below:

	NO. OF CLAIMS		EXTRA CLAIMS	RATE	AMOUNT
Total Claims	11	-20	0	\$18.00	\$0.00
Independent Claims	2	-3	0	\$80.00	\$0.00
Multiple Dependent Claim(s)					\$0.00
Basic Fee					\$710.00
Total of Above Calculations					\$710.00
Less ½ for Small Entity					\$0.00
Assignment & Recording Fee					\$40.00
Total Fee					\$750.00



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PATENT TRADEMARK OFFICE

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